

# **ECE 340:** **Semiconductor Electronics**

## **Chapter 4: Excess Carriers in Semiconductors**

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# Outline

- ➔ • Optical absorption
- Luminescence
- Carrier lifetime and photoconductivity
  - Direct recombination of electrons and holes
  - Steady state carrier generation; Quasi-Fermi levels
  - Photoconductive devices

# Turn the light **ON** semiconductors

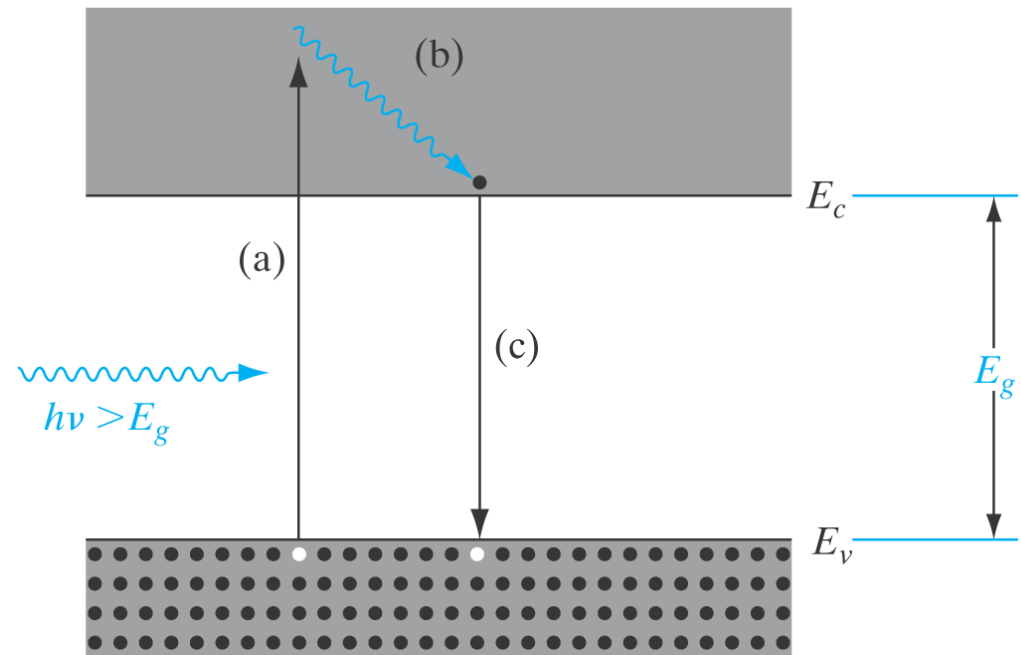
When we turn light on, we can generate excess electron-hole pairs (EHPs), depending on the light frequency (energy)

- If  $h\nu \geq E_g$

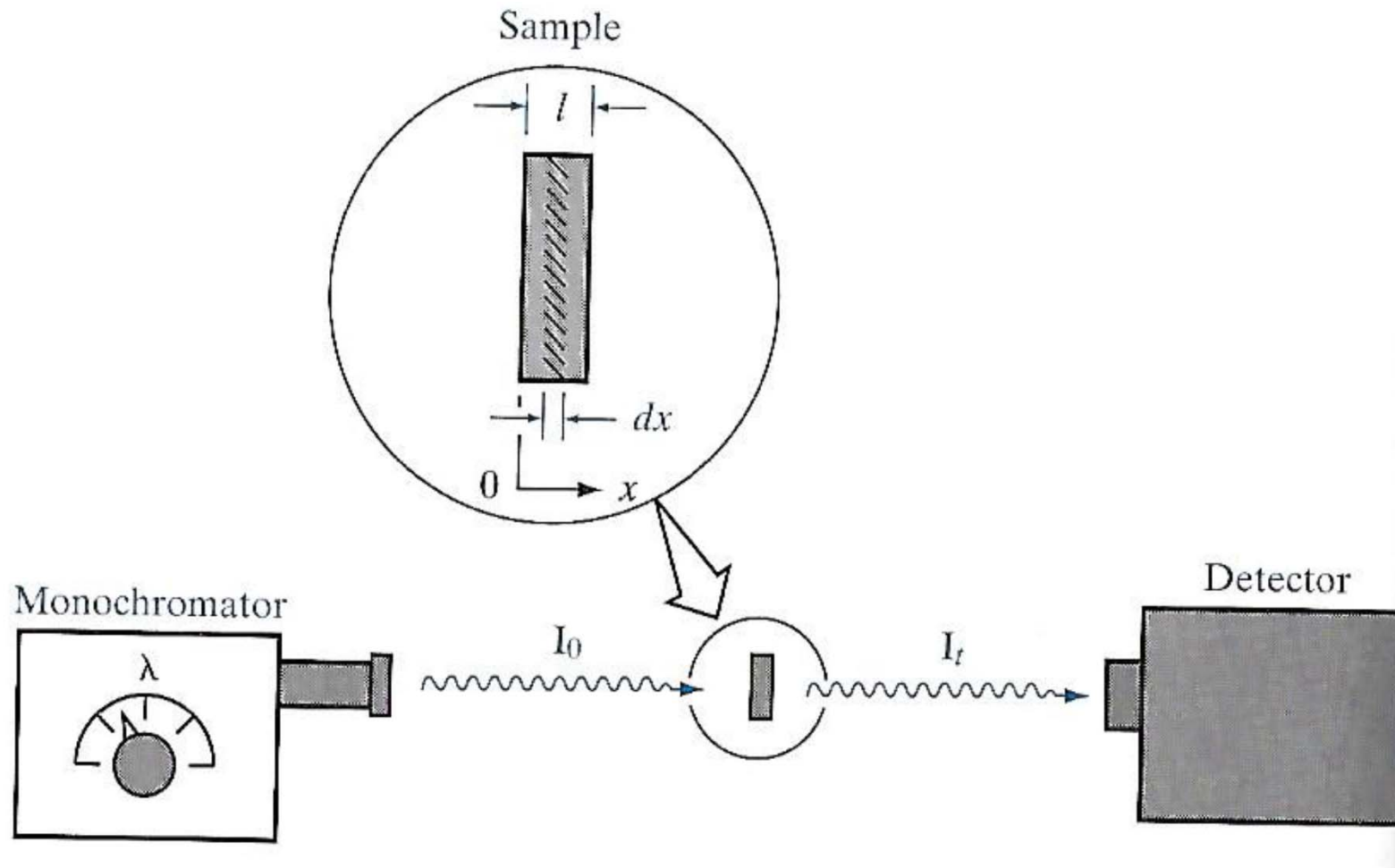
photon can be absorbed, and generate EHP

- If  $h\nu < E_g$

no light absorption and EHP generation.



# Optical absorption experiment



# Transmitted light and absorption coefficient

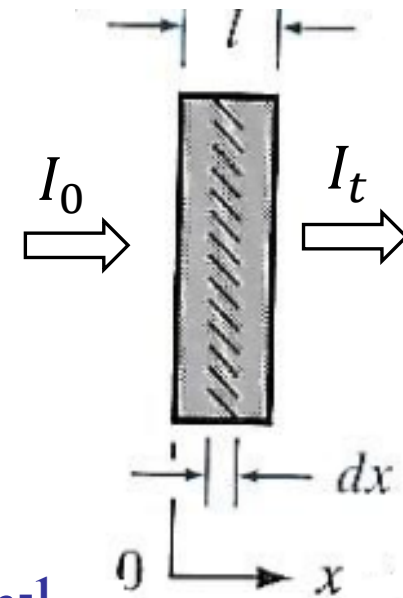
- Assume photon with  $h\nu \geq E_g$  , intensity  $I_0$  , sample thickness  $l$ , then

$$-\frac{dI(x)}{dx} = \alpha I(x)$$

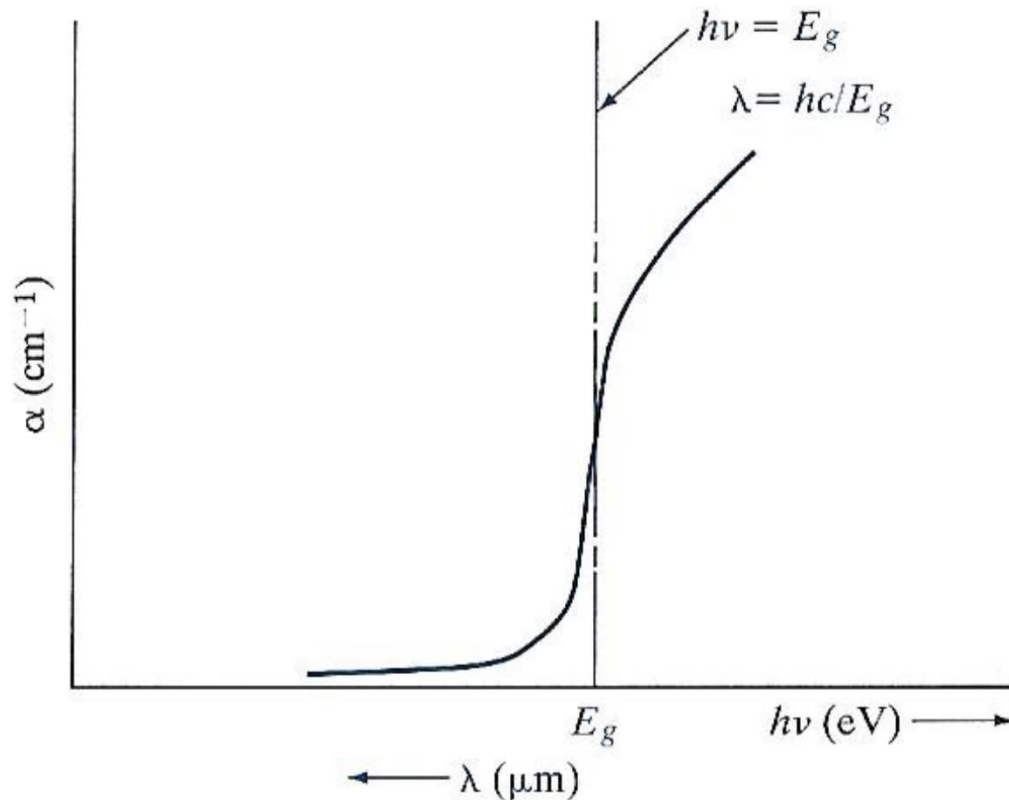
- The intensity of transmitted photons is:

$$I_t = I_0 e^{-\alpha l}$$

where  $\alpha$  is called absorption coefficient. Unit:  $\text{cm}^{-1}$



# Dependence of optical absorption on the wavelength of incident light

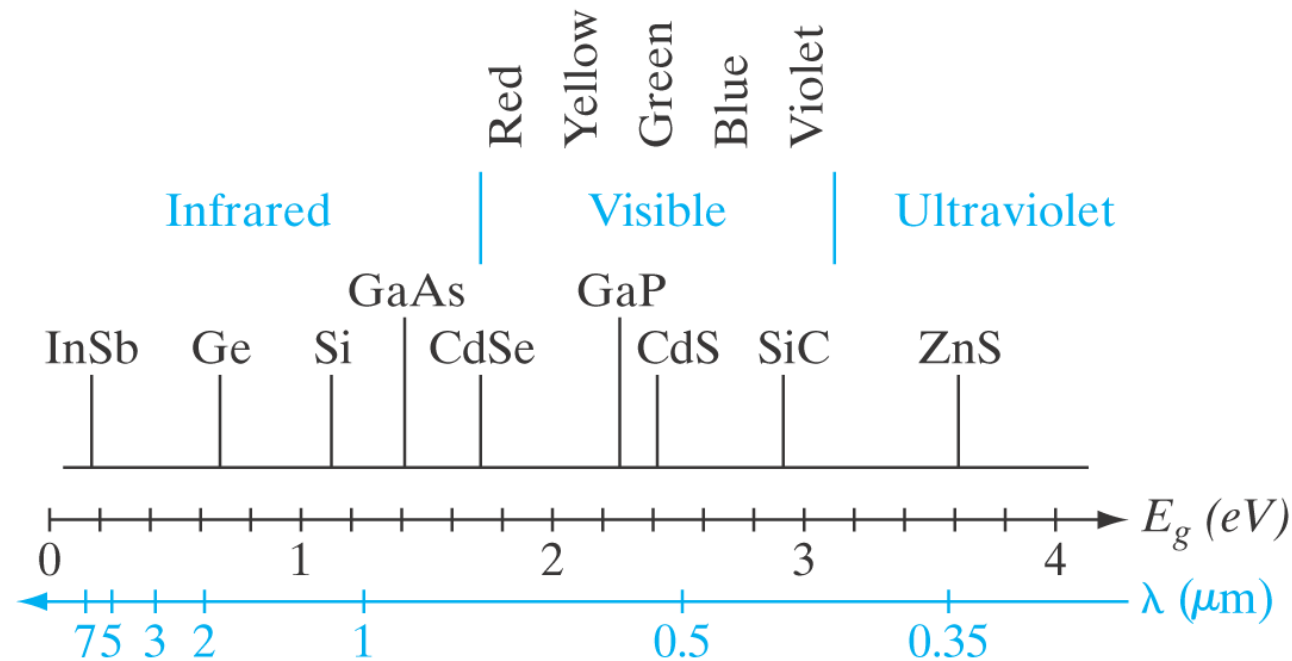


If  $E$  is in eV, and  $\lambda$  in  $\mu\text{m}$ , then


$$\lambda = \frac{1.24}{E}$$

- A semiconductor absorbs photons with energies equal to or larger than the band gap.

# Band gaps of common semiconductors relative to the optical spectrum



# Outline

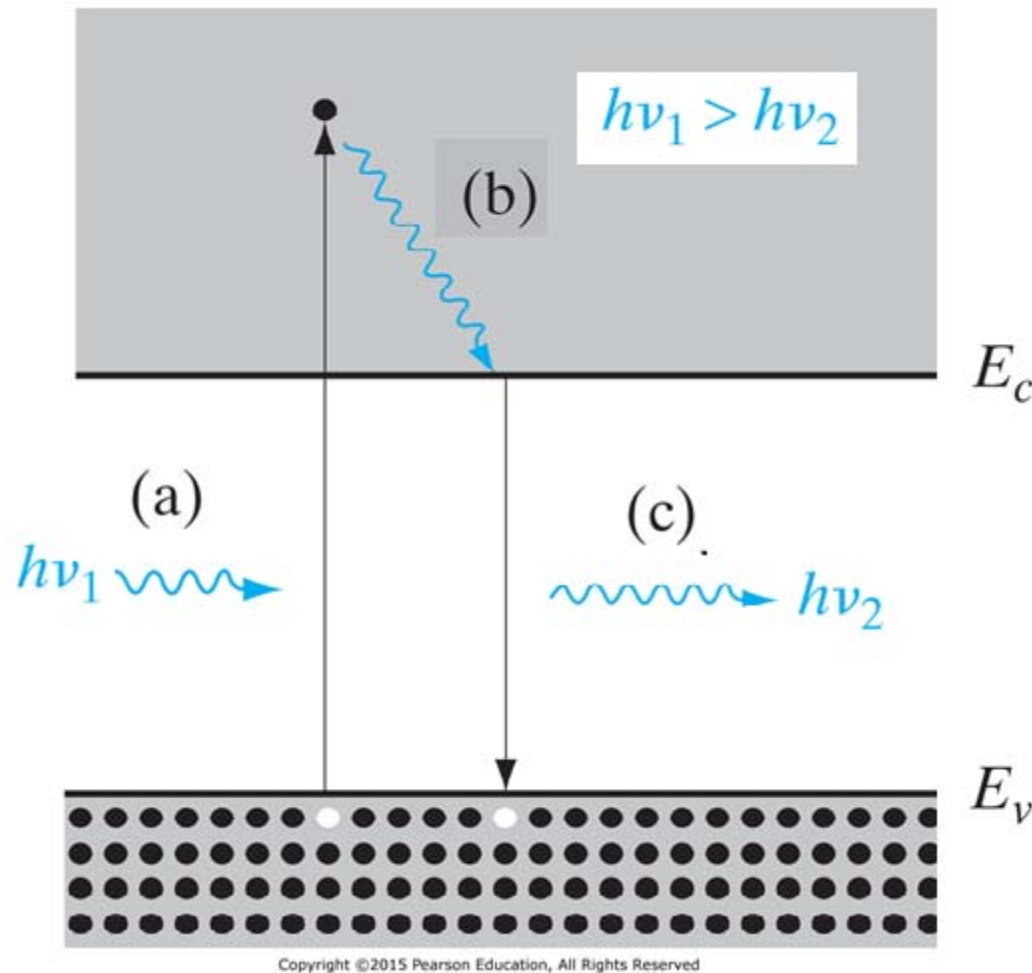
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# Luminescence

- Luminescence: light emission resulting from recombination of the excited carriers.
- According to the excitation mechanism, there are different types of luminescence:
  - Photoluminescence: carrier are excited by photon absorption
  - Electroluminescence: carrier excitation occurs by the introduction of current into the sample

# Photoluminescence



If  $h\nu < E_g$ , no light absorption

If  $h\nu \geq E_g$ , then

- (a) Absorb photon with energy  $h\nu_1$
- (b) Give up extra kinetic energy  $h\nu_1 - E_g$  to lattice as heat
- (c) Recombination, release photon with energy  $E_g$

# Excess carrier

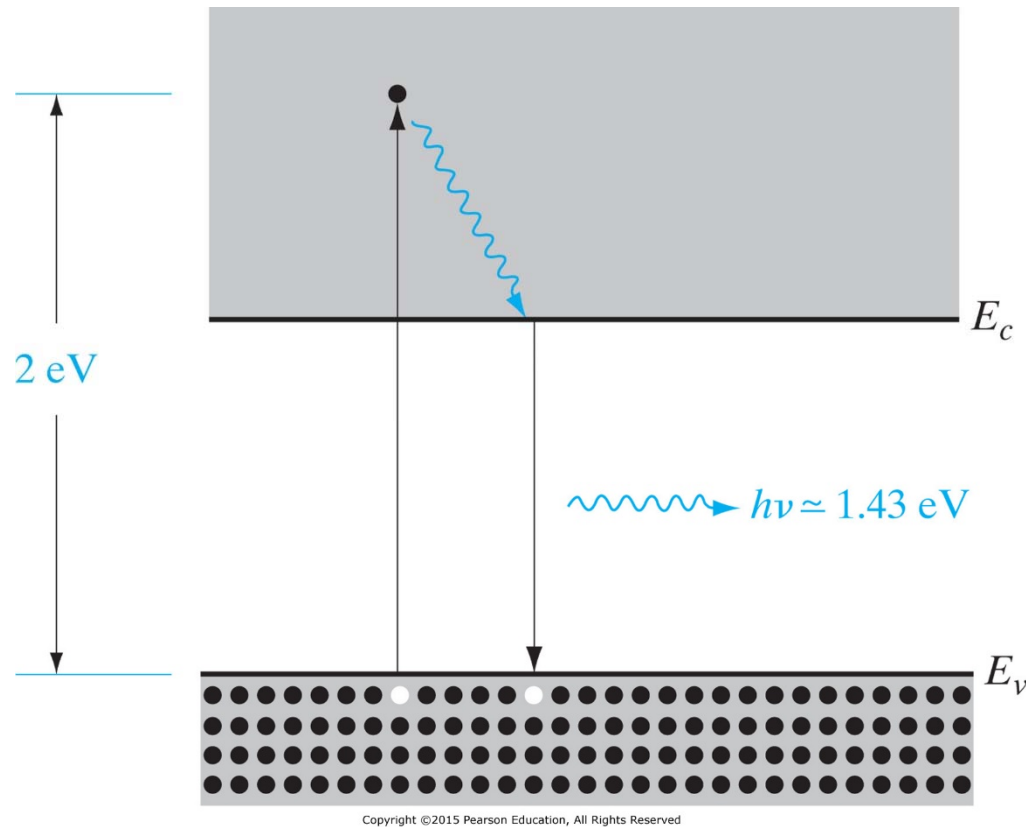
- Incident photon flux is the number of incident photons per unit time:

$$\Phi = \frac{P_{op}}{h\nu}$$

Incident light power (unit: watt = J/s)

Photon energy (unit: J)

# Example



A 0.46- $\mu\text{m}$  thick sample of GaAs is illuminated with monochromatic light of  $h\nu=2\text{ eV}$ . The absorption coefficient  $\alpha$  is  $5 \times 10^4\text{ cm}^{-1}$ . The power incident on the sample is 10mW.

- Find the total energy absorbed by the sample per second (J/s).
- Find the rate of excess thermal energy given up by the electrons to the lattice before recombination(J/s).
- Find the number of photons per second given off from recombination events, assuming perfect quantum efficiency.

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## Recall: Intrinsic material at thermal equilibrium

- Recombination rate is determined by the number of electron and hole concentration:

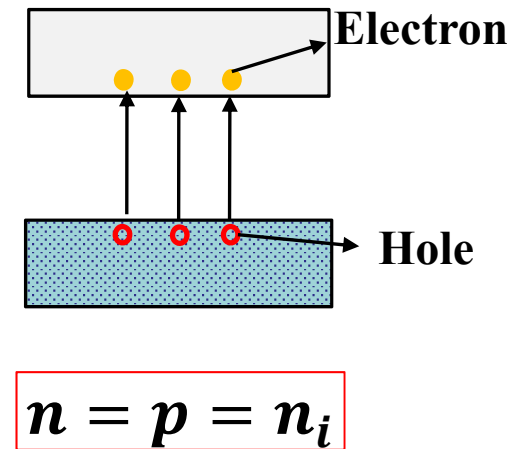
$$r_i = \alpha n_i^2$$

$\alpha$  is a constant

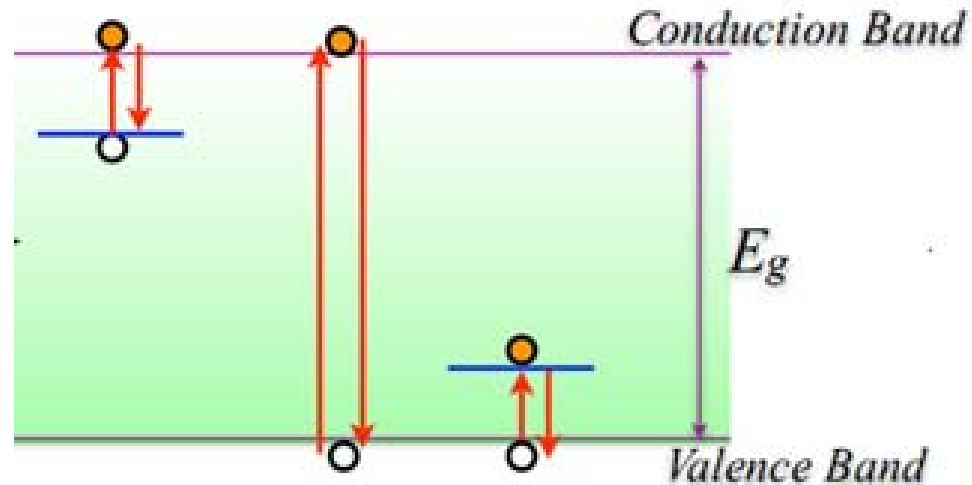
- At equilibrium:

$$g_i = r_i$$

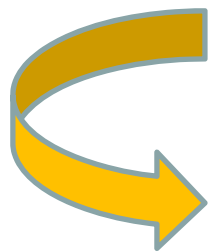
$$\Rightarrow g_i = \alpha n_i^2$$



# Extrinsic material at thermal Equilibrium



**Generation rate = recombination rate**

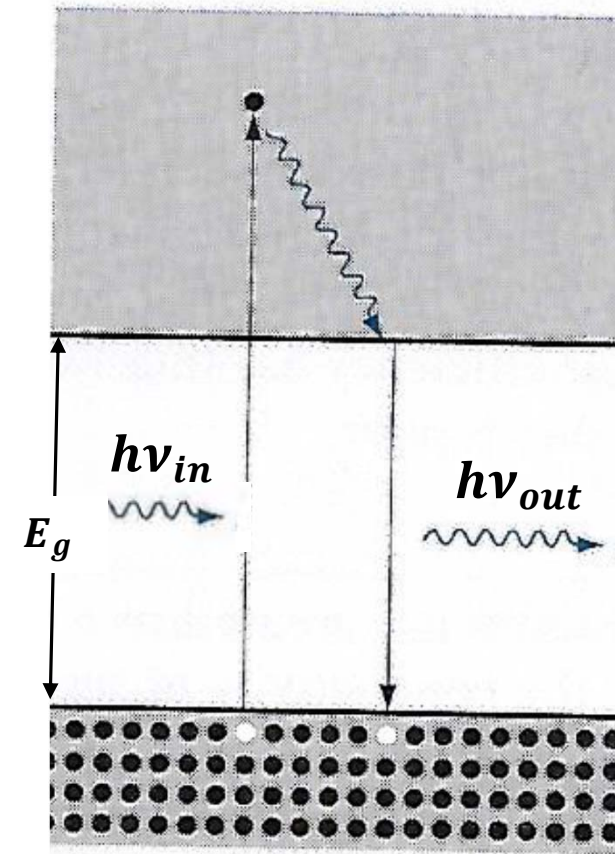


$$\alpha n_i^2 = \alpha n_0 p_0$$

$$n_0 p_0 = n_i^2$$

# Shine light: recombination of electrons and holes

- Direct EHP recombination occurs spontaneously, emitting a photon of energy  $E_g$
- Carrier concentration notation:  
Equilibrium carrier concentration:  $n_0, p_0$   
Initial excess carrier concentration  $\Delta n, \Delta p$ .  
Excess carrier concentration at any time:  $\delta n(t), \delta p(t)$





# Excess carrier concentration

- The net rate of change in the conduction band electron concentration is:

$$\frac{dn(t)}{dt} = \underbrace{\alpha_r n_i^2}_{\text{Generation rate}} - \underbrace{\alpha_r n(t)p(t)}_{\text{Recombination rate}}$$

Generation rate is not equal to recombination rate at non-equilibrium condition!

**Recall: at thermal equilibrium condition  
generation rate = recombination rate ( $\alpha_r n_i^2 = \alpha_r n_0 p_0$ )**

- Assume at  $t=0$ , excess electron-hole population is created:  $\Delta n = \Delta p$ . The net rate of change in electron concentration is:

$$\frac{d\delta n(t)}{dt} = \alpha_r n_i^2 - \alpha_r [n_0 + \delta n(t)][p_0 + \delta p(t)]$$

- Note  $\alpha_r n_i^2 = \alpha_r n_0 p_0$ .

For low level injection,  $[\delta n(t)]^2$  is very small.

If material is p type ( $p_0 \gg n_0$ ), then the rate of change is:

$$\frac{d\delta n(t)}{dt} = \alpha_r p_0 \delta n(t)$$

# Excess carrier concentration

- The excess carrier concentration:

$$\delta n(t) = \Delta n e^{-\alpha_r p_0 t} = \Delta n e^{-t/\tau_n}$$

Where  $\tau_n = (\alpha_r p_0)^{-1}$ , electron recombination lifetime

- If material is n type, the minority carrier is hole:

$$\delta p(t) = \Delta p e^{-\alpha_r n_0 t} = \Delta p e^{-t/\tau_p}$$

where  $\tau_p = (\alpha_r n_0)^{-1}$ , hole recombination lifetime

- More generally:

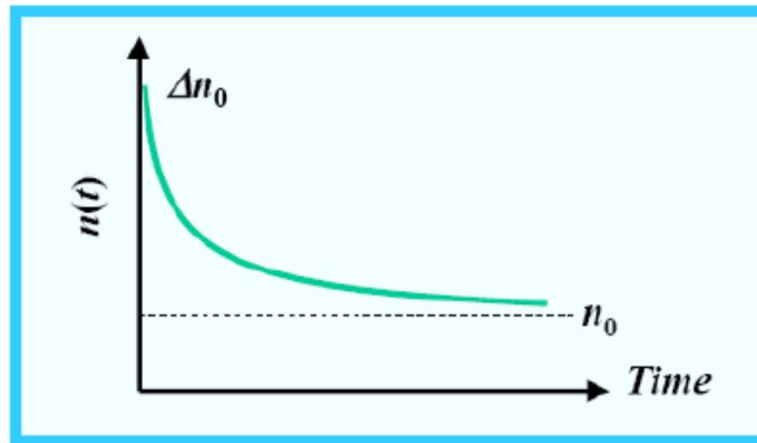
$$\tau = \frac{1}{\alpha_r (n_0 + p_0)}$$

# Total carrier concentration

- Electron and hole concentration as a function of time

$$n(t) = n_0 + \Delta n e^{-t/\tau_n}$$

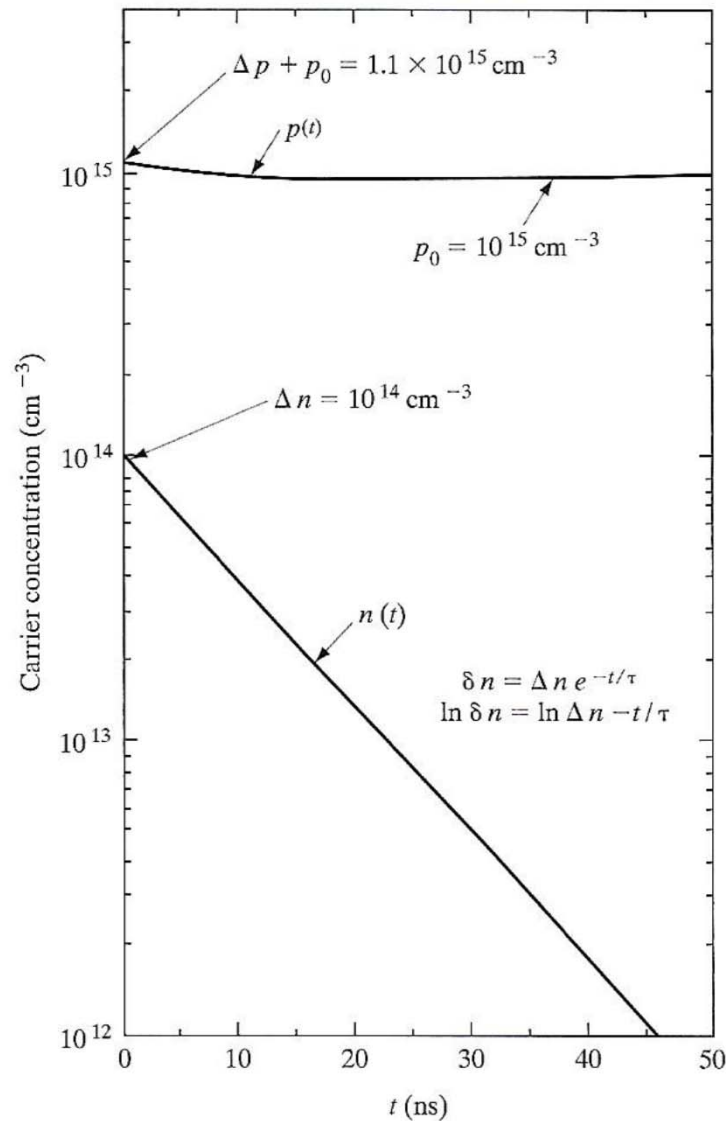
$$p(t) = p_0 + \Delta p e^{-t/\tau_p}$$



## Example 1

- Assume a sample of GaAs is doped with  $10^{15} \text{ acceptors/cm}^3$ . The intrinsic carrier concentration of GaAs is approximately  $10^6 \text{ cm}^{-3}$ , Now if  $10^{14} \text{ EHP/cm}^3$  are created at  $t=0$ , carrier recombination lifetime is  $\tau_n = \tau_p = 10^{-8} \text{ s}$ . Find out the electron and hole carrier concentration as a function of time.

# Decay of excess electrons and hole by recombination



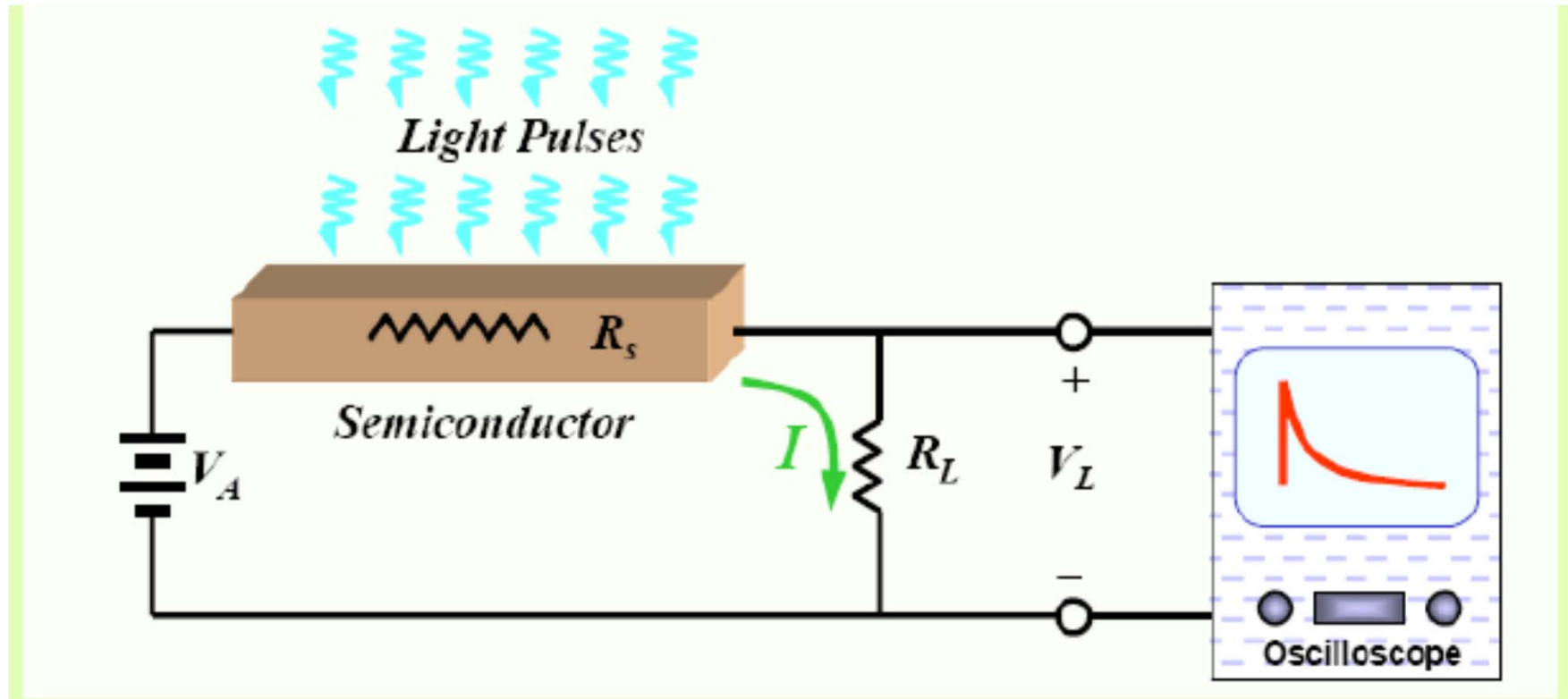
In p type material:

$$p_0 > n_0 \quad \text{and} \quad \Delta n = \Delta p$$

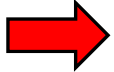
$$\Rightarrow \frac{\Delta p}{p_0} < \frac{\Delta n}{n_0}$$

- **Minority** carrier concentration: **large** percentage change
- **Majority** carrier concentration: **small** percentage change

# Experiment setup for photoconductivity and recombination lifetime measurement



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# Steady state carrier generation

- At thermal equilibrium:

$$g(T) = \alpha_r n_i^2 = \alpha_r n_0 p_0$$

- If a steady light is shone on the sample,

$$g(T) + g_{op} = \alpha_r np = \alpha_r (n_0 + \delta n)(p_0 + \delta p)$$

Thermal generation rate

Optical generation rate

Recombination rate

- For steady state recombination and no trapping,  $\Delta n = \Delta p$ , then

$$\cancel{g(T)} + g_{op} = \cancel{\alpha_r n_0 p_0} + \alpha_r (n_0 + p_0) \delta n + \cancel{\delta n^2}$$

# Excess carrier concentration

- For low level injection ( $\delta n^2$  is small), then:

$$g_{op} = \alpha_r(n_0 + p_0)\delta n = \frac{\delta n}{\tau}$$

- The excess carrier concentration:

$$\delta n = \delta p = g_{op}\tau$$

# Quasi-Fermi Level

- At thermal equilibrium, carrier concentration is expressed by Fermi level:

$$n = n_i e^{(E_F - E_i)/kT}$$

$$p = p_i e^{(E_i - E_F)/kT}$$

- At steady state, the carrier concentration can be written in similar form by defining separate quasi-Fermi levels:

$$n = n_i e^{(F_n - E_i)/kT}$$

$F_n$ : quasi-Fermi level for electron

$$p = p_i e^{(E_i - F_p)/kT}$$

$F_p$ : quasi-Fermi level for hole

## Example

- Assume that  $10^{13}$  EHP/cm<sup>3</sup> are created optically every microsecond in a Si sample with  $n_0=10^{14}$ cm<sup>-3</sup> and  $\tau_n = \tau_p = 2\mu s$ . Where is the quasi-Fermi level  $F_n$  and  $F_p$ ?

# Quasi-Fermi level and carrier concentration

	Thermal equilibrium carrier concentration $n_0, p_0$	Excess carrier concentration $\Delta n, \Delta p$	Percentage change in carrier concentration $\Delta n/n_0, \Delta p/p_0$	Derivation of quasi-Fermi level from equilibrium Fermi level $F_n - E_i, E_i - F_p$
Majority carrier	High	same	Small	Small
Minority carrier	Low	same	Large	Large

- At equilibrium:

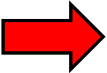
$$F_n = F_p = E_F$$

## Example

A semiconductor sample is illuminated with a steady state laser beam characterized by a photon energy of 1 eV and an intensity of 10 mW. The semiconductor has a cross section  $A=10^{-2}\text{cm}^2$  and a thickness of  $1\mu\text{m}$ . The minority carrier lifetime is  $\tau=10\text{ ns}$ .

- a) By assuming the intensity of the transmitted light is negligible, compute the photon absorption rate (number of photons absorbed/sec)?
- b) If each photon produces an electron-hole pair (EHP), compute the optical generation rate?
- c) What is the concentration of excess minority carrier?

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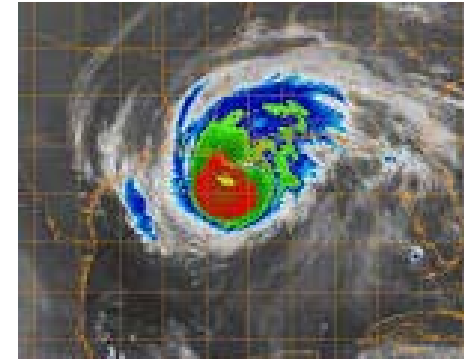
# Application of photodetectors



**Digital camera**



**Street light**



**Infrared Satellite**



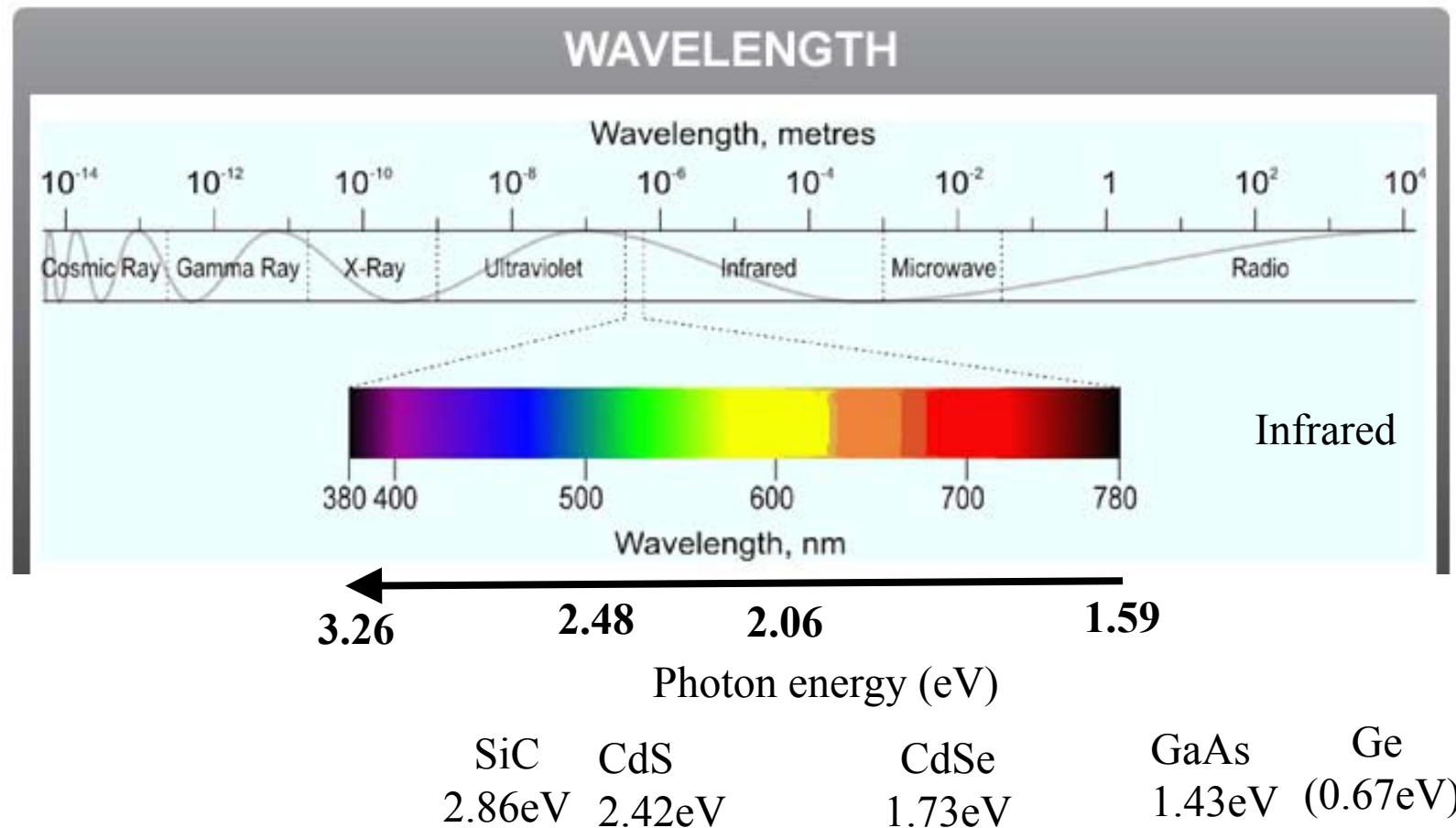
**Automatic door**



**Night vision camera**



# Semiconductor materials for photodetectors



- **Semiconductor are most sensitive to photons with energies equal to the band gap or slightly more energetic than band gap.**

# Photoconductivity of a photodetector

- Under steady state light illumination, the excess carrier concentration is:

$$\delta n = g_{op}\tau_n \quad \delta p = g_{op}\tau_p$$

- The conductivity change due to the light, called photoconductivity is:

$$\Delta\sigma = \underset{\substack{\swarrow \\ \text{With light}}}{\sigma} - \underset{\substack{\searrow \\ \text{Without light}}}{\sigma_0} = q(\delta n\mu_n + \delta p\mu_p)$$

$$\Rightarrow \Delta\sigma = qg_{op}(\tau_n\mu_n + \tau_p\mu_p)$$